



520.36911CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	T. ONO, et al	RECEIVED
Serial No.:	09/249,292	DEC 23 2003
Filed:	February 12, 1999	TC 1700
For:	METHOD AND APPARATUS FOR TREATING SURFACE OF SEMICONDUCTOR	
Group:	1763	
Examiner:	A. Olsen	

AMENDMENT

Mail Stop Fee-Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 15, 2003

Sir:

In response to the Office Action August 15, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.